## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: LYU, Yi Yeol et al. Conf.:

Appl. No.: Cont. of 10/105,723 Group:

Filed: July 18, 2003 Examiner:

For: SILOXANE-BASED RESIN AND METHOD FOR

FORMING INSULATING FILM BETWEEN INTERCONNECT LAYERS IN SEMICONDUCTOR

THIERCONNECT LAYERS IN SEMICONDUCT

DEVICES BY USING THE SAME

INFORMATION DISCLOSURE STATEMENT
(SUBMISSION WITH CONTINUATION-IN-PART OR
RULE 1.53(b) CONTINUATION OR DIVISIONAL APPLICATION)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

July 18, 2003

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

## I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications, or other information submitted for consideration by the Office are listed on the PTO-1449 form(s), attached hereto.

## II. REFERENCES PREVIOUSLY CITED OR SUBMITTED

Pursuant to 37 C.F.R. § 1.98(d), consideration of information listed on the PTO-1449 form(s) is requested since any patents, publications, or other information which are listed on the PTO-1449 form(s) but for which copies are not enclosed herewith, were previously cited by or submitted to the PTO in one of the following applications which has been relied upon for an earlier filing date under 35 U.S.C. § 120:

U.S. Appl. No(s). 10/105,723 U.S. Filing Date(s)
March 27, 2002

## III. FEES

This Information Disclosure Statement is being filed concurrent with the filing of a continuation-in-part, continuation, or divisional patent application; therefore, no fee is required.

If the Examiner has any questions concerning this IDS or requires a copy of any of the references cited but not provided, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule and charge the appropriate fee to Deposit Account No. 02-2448.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Joseph A. Kolasch, #22,463

*O*hn JAK/CAM/gh 3811-0122P P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachment(s):	$\boxtimes$	PTO-1449	)(s)			
		References				
		Foreign	Search	Report		

☐ Other:

(Rev. 04/29/03)

Form PTO-1449			ATTY DOCKET NO. 3811-0122P		Cont. of 10/105,723							
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		LYU, Yi Yeol et al.										
(Use several sheets if necessary)		July 18, 2003		GROUP								
U.S. PATENT DOCUMENTS												
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILIN IF APPE	G DATE COPRIATE					
	3,615,272	1971-10-26	Collins et al.									
	5,010,159	1991-04-23	Bank et al.									
	6,232,424	2001-05-15	Zhong et al.									
	6,000,339	1999-12-14	Matsuzawa				-					
	5,853,808	1998-12-29	Arkles et al.									
	5,378,790	1995-01	Michalczyk et al.									
	6,284,834	2001-09	Kirchmeyer et al.									
	6,413,446	2002-07	Mechtel et al.									
	FOI	REIGN PATENT	DOCUMENTS									
T	DOCUMENT NUMBER DATE		COUNTRY CLAS	CLASS	SUB CLASS	TRANSLATION						
						YES	NO					
				,								
		<u> </u>										
	<u></u>											
		<u> </u>										
OTHER journal, serie	DOCUMENTS (Include Name of the author), symposium, catelog, etc.) dete, page(s), voi	nor (in CAPITAL LETTERS), lume-issue number(s), publ	title of the article (when appropri	ate), tit: blished.	le of the ite	em (book, r	nagazine,					
						_						
EXAMINER			DATE CONSIDERED									
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.												